

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 3742**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re the Application of**

**Kazuo TANAKA et al.**

**Group Art Unit: 3742**

**Application No.: 10/550,202**

**Examiner: S. PAIK**

**Filed: October 20, 2005**

**Docket No.: 125385**

**For: SUBSTRATE PROCESSING EQUIPMENT**

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**Sir:**

**In reply to the July 23, 2007 Office Action, the period for response thereto having been extended to November 23, 2007 by the attached Petition and fee, and in view of the October 4, 2007 and November 15, 2007 interviews, please consider the following:**

**Amendments to the Claims as reflected in the listing of claims; and**

**Remarks.**